



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Uzoh et al.
 Appl. No. : 10/698,878
 Filed : October 31, 2003
 For : METHODS AND DEPOSITING
 HIGH YIELD AND LOW
 DEFECT DENSITY
 CONDUCTIVE FILMS IN
 DAMASCENE STRUCTURES
 Examiner : Van, Luan V.
 Group Art Unit : 1753

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 5, 2006

(Date)

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 Adeel S. Akhtar, Reg. No. 41,394

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

Mail Stop AF

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action mailed on April 5, 2006. Please amend the above-identified application as set forth herein and consider the remarks that follow.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.